	Application No.	Applicant(s)	
	10/076,012	LIU ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Brian J. Sines	1743	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet w (OR REMAINS) CLOSED if or other appropriate comm	ith the correspondence addresent this application. If not included	d ource THIC
1. This communication is responsive to the response filed 7/2	<u>21/2004</u> .	•	
2. ☑ The allowed claim(s) is/are <u>1-14</u> .			,
3. \boxtimes The drawings filed on <u>2/11/2002</u> are accepted by the Exam	niner.		
 4. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 	been received.		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the			
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file ENT of this application.	e a reply complying with the requ	iirements
 A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give 	itted. Note the attached EX s reason(s) why the oath o	AMINER'S AMENDMENT or NO r declaration is deficient.	TICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the processing of the sheet of the	on's Patent Drawing Review Amendment / Comment on the second of the sec	r in the Office action of	ack) of
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT F 	sit of BIOLOGICAL MATI	ERIAL must be submitted. No DLOGICAL MATERIAL.	te the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)		formal Patent Application (PTO-	152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview S	ummary (PTO-413),	,
Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date		Mail Date Amendment/Comment	
4. Examiner's Comment Regarding Requirement for Deposit	8. 🛭 Examiner's	Statement of Reasons for Allowa	ance
of Biological Material	9. 🗌 Other	_•	

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DETAILED ACTION

Election/Restrictions

Claims 1 - 14 have been rejoined for examination.

Specification

The disclosure is objected to because of the following informalities: There are numerous blanks in the specification referring to U.S. patent application serial numbers.

Appropriate correction is required.

Allowable Subject Matter

Claims 1 - 14 are allowed.

The following is an examiner's statement of reasons for allowance:

Regarding claim 1, the cited prior art neither teach nor fairly suggest a microfluidic device comprising: a substrate comprising at least first and second blocks that are configured to slide relative to each other; at least one reaction channel defined on the first block along which a sample migrates; at least one sample channel defined on the first block; at least one sample metering channel defined on the second block; and a sliding means for sliding the second block relative to the first block from a first position at which a sample is loaded from the sample channel into the sample metering channel, to a second position at which the sample is introduced from the sample metering channel to the reaction channel.

Regarding claim 13, the cited prior art neither teach nor fairly suggest a microfluidic device comprising: a substrate comprising at least first and second blocks that are configured to slide relative to each other; at least one sample channel defined on the first block; at least one sample metering channel defined on the first block; at least one waste reservoir on the second

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block; and a sliding means for sliding the second block relative to the first block from a first position at which a sample is loaded from the sample channel into the sample metering channel with excess discharged to the waste reservoir in the second block, to a second position at which the sample is introduced from the sample metering channel to the reaction channel.

Regarding claim 14, the cited prior art neither teach nor fairly suggest a method for injecting a sample into a reaction channel defined on a microfluidic device, wherein the method comprises the steps of: providing a substrate comprising at least first and second blocks that are configured to slide relative to each other; defining at least one reaction channel on the first block along which the sample migrates; defining at least one sample channel on the first block; defining at least one sample metering channel on the second block; sliding the second block relative to the first block from a first position at which sample is loaded from the sample channel into the sample metering channel, to a second position at which the sample is introduced from the sample metering channel to the reaction channel.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure: Yoshida et al. teach a rotary valve apparatus. Bemis et al. teach a metering valve assembly. Bakalyar teaches a sample injector apparatus. Stone teaches a rotating sampling valve

apparatus. Wylie et al. teach a fluid control valve apparatus. Laursen teaches a rotatable rotor assembly for a chemical synthesis apparatus.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Brian J. Sines, Ph.D. whose telephone number is (571) 272-1263. The examiner can normally be reached on Monday - Friday (11 AM - 8 PM EST).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Jill A. Warden can be reached on (571) 272-1267. The fax phone number for the organization where this application or proceeding is assigned is (703)-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Polli Warden
Supervisory Patent Examiner
Technology Center 1700